

<b>Notice of References Cited</b>	Application/Control No. 09/868,866	Applicant(s)/Patent Under Reexamination HECKMEIER ET AL.	
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	C	US-5368772	11-1994	Rieger et al.	252/299.63
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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